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NOV 23 2004 PATENT
Attorney Docket No. 3381

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Michael P. Mittmann et al.

Serial No: 09/824,931

Filing Date: 4/3/2001

Title: Photolithographic Method and
System for Efficient Mask Usage in
Manufacturing DNA Arrays

Examiner: Ardin H. Marschel

Group Art Unit: 1631

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT/RESPONSE

Dear Examiner Marschel:

In response to the Final Office Action Mailed September 23, 2004, Applicants respectfully submit the following amendments and remarks, and request reconsideration of the present application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.